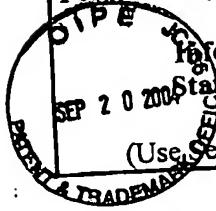


<p>Form 1449 (Modified)</p> <p>Information Disclosure Statement By Applicant</p> <p>(Use Several Sheets if Necessary)</p>				Atty Docket No. NOVLP090/NVLS-2888	Application No.: 10/733,858
				Applicant: Zhu et al.	
				Filing Date December 10, 2003	Group 2812



U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
JKS	A1	5,705,419	01/1998	Perry et al.			
	A2	5,342,801	08/1994	Perry et al.			
	A3	5,385,857	01/1995	Solo de Zaldívar			
	A4	4,361,461	11/1982	Chang			
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✓	A8	5,246,885	9/1993	Braren et al.			

Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation Yes	Translation No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
JKS	C1	Papasouliotis et al., "Method of Chemical Modification of Structure Topography", U.S. Patent Application No. 10/004,386, filed December 3, 2001.
JKS		Date Considered 4/15/05

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Form 1449 (Modified)		Atty Docket No. NOVLP090/NVLS-2888	Application No.: 10/733,858
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Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation
							Yes
							No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication	Date Considered

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Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
JKS		Date Considered 4/15/03

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Form 1449 (Modified)

**Information Disclosure
Statement By Applicant**

(Use Several Sheets if Necessary)

Atty Docket No.
NOVLP090/NVLS-2888

Application No.:
10/733,858

Applicant:

Zhu et al.

Filing Date

December 10, 2003

Group

2812

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Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
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	A2	6,265,269	07/24/01	Chen et al.			
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Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation
							Yes
							No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	C1	
Examiner		Date Considered
		4/15/05

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